



EXPEDITED PROCEDURE
Examining Group Number 2800

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amendment

D.P.

6/7/04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-------------|--|-----------------|---------------------------|
| Applicant: | David C. Chu | Examiner: | Demetrius R. Pretlow |
| Serial No.: | 10/052,673 | Group Art Unit: | 2863 |
| Filed: | January 17, 2002 | Docket No.: | 10020043-1 (A310.119.101) |
| Due Date: | May 31, 2004 | | |
| Title: | SYSTEM AND METHOD FOR INTERFEROMETER NON-LINEARITY COMPENSATION | | |

RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is responsive to the Final Office Action mailed March 31, 2004.